

DATE AND LOCATION	CONFERENCE	PAPER OR EVENT
<p>April 13-15, 2015 Munich, Germany</p>	<p>15th European Advanced Process Control Manufacturing (<u>APCM</u>) Conference</p>	<p><i>An Approach for Effective Development and Maintenance of Prediction Technologies in Semiconductor Manufacturing</i> - Michael Armacost, John Scoville and Parris Hawkins, Applied Materials; James Moyne, University of Michigan</p>
<p>May 3-6, 2015 Saratoga Springs, New York</p>	<p>Advanced Semiconductor Manufacturing Conference (<u>ASMC</u>) 2015</p>	<p><i>Big Data Emergence in Semiconductor Manufacturing Advanced Process Control</i> - Jamini Samantaray and Michael Armacost, Applied Materials; James Moyne, University of Michigan</p> <p><i>Predictive Maintenance in Semiconductor Manufacturing: Moving to Fab-Wide Solutions</i> - Jimmy Iskandar, Michael Armacost, Parris Hawkins and Kommisetti Subrahmanyam, Applied Materials; James Moyne, University of Michigan</p>
<p><i>Coming to a location near you!</i></p>	<p><b>Applied Global Services 2015 Customer Technical Symposium Series</b></p>	<p>Over 300 customers attended our symposiums in 2014 and the first 2015 Symposium was held on March 19th in Shanghai, China. Learn more at <a href="http://www.appliedmaterials.com">www.appliedmaterials.com</a>, and join us this year to explore ways to unlock greater productivity in <i>your</i> fab.</p>